

Notice of References Cited	Application/Control No. 10/722,218		Applicant(s)/Patent Under Reexamination CHENG ET AL.	
	Examiner Douglas A Wille		Art Unit 2814	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-20040195646	10-2004	Yeo et al.	257/527
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*	D	US-6,187,641 B1	02-2001	Rodder et al.	438/299
*	E	US-6,348,390 B1	02-2002	Wu, Shye-Lin	438/305
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	G	US-2004/0175872	09-2004	Yeo et al.	438/154
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Shimizu et al. Local mechanical stress control, IEDM 2001, pp 433-436
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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